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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**Daisuke KOMADA, et al.**

Group Art Unit: 1756

Serial No.: 10/058,426

Examiner: **BARRECA, Nicole M.**

Filed: **January 30, 2002**

Confirmation No.: 4298

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
SILICON CARBIDE FILM**

Attorney Docket No.: 020060

Customer Number: 38834

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 26, 2004

Sir:

In response to the Office Action dated July 25, 2003, please amend the above identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.